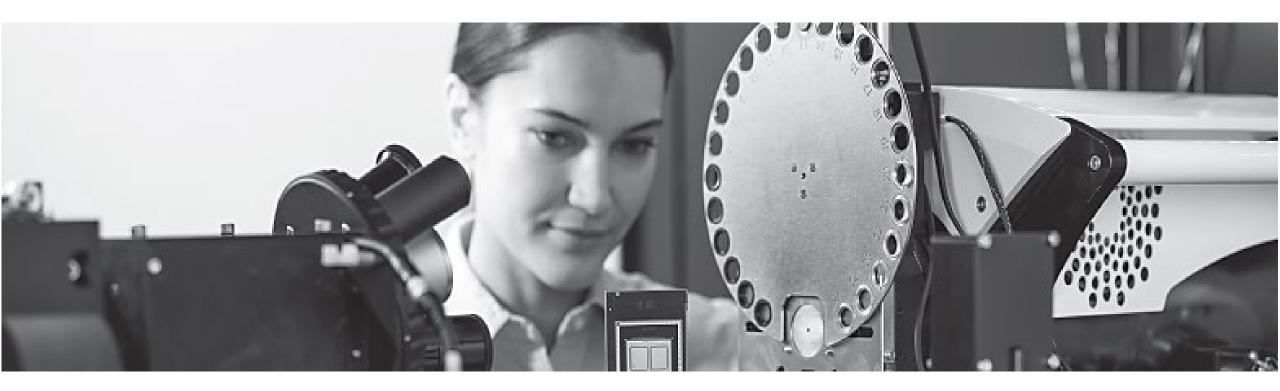
## **Opportunities in 3D and 4D Imaging with X-ray Microscopy** In the materials research laboratory



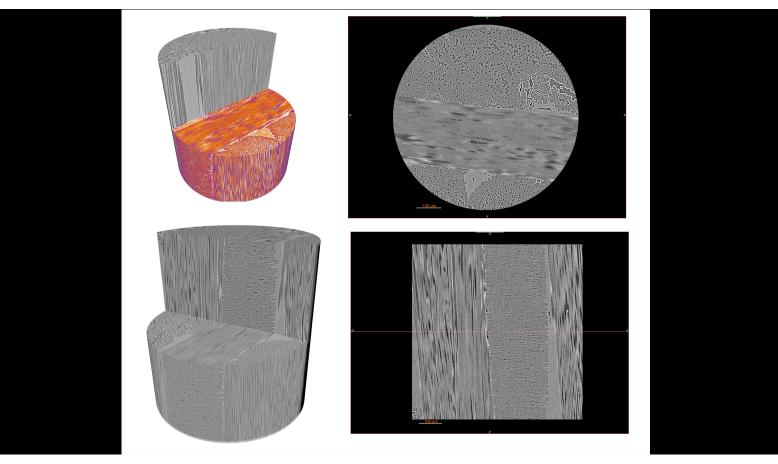


John Kelley Electron, Ion & X-ray Microscopy Specialist – Materials *X-ray Microscopy Workshop* Purdue University 09 July 2019

#### Why Do We Use X-ray Microscopy? Materials characterization in 3D



→ Visualize, characterize, and quantify internal three dimensional structures of objects without physical cutting



XRM - Carbon Composite (video) XRM - Li-ion batter (video)

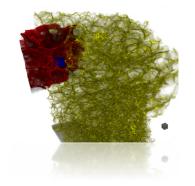
Ceramic matrix composite, imaged at in situ working distance with RaaD

#### Agenda

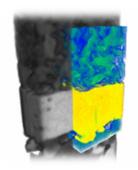




#### **Overview of ZEISS X-ray Microscopy in Materials Science**



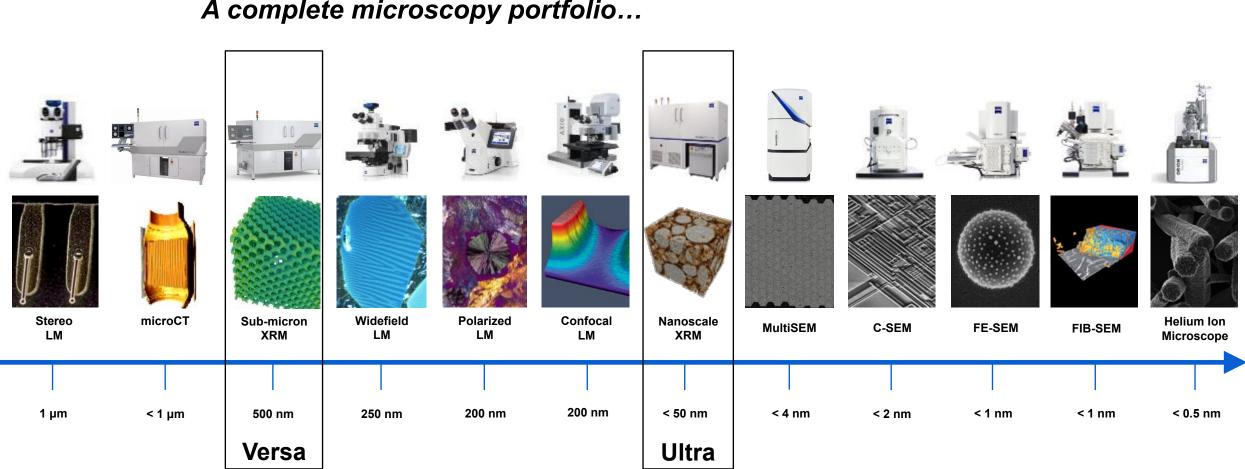




**ZEISS Xradia Ultra – Technology and Applications** 

### **ZEISS Microscopy Portfolio** Multi-Scale Characterization for Multi-Scale Research





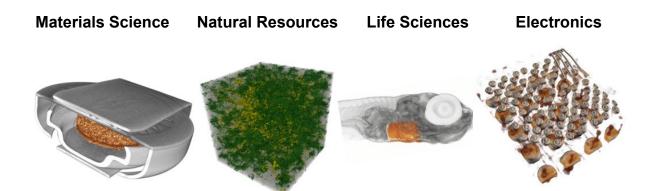
#### A complete microscopy portfolio...

...to address multi-scale research challenges.

#### ZEISS X-ray Microscopy Background

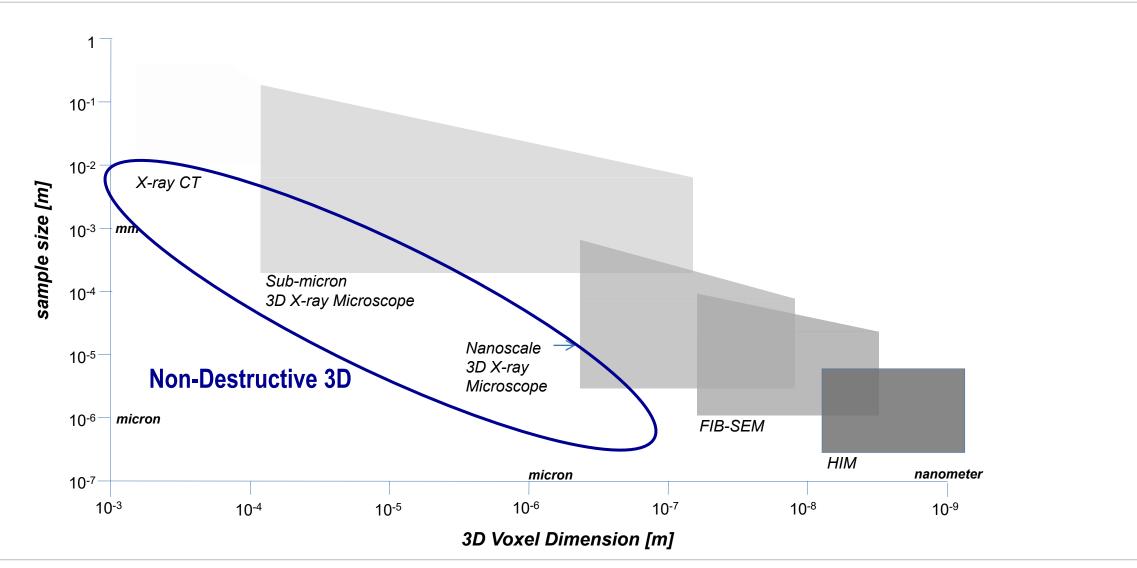


- Xradia was founded in 2000 and acquired by ZEISS in July 2013
- Pioneer in ultra-high resolution 3D X-ray microscopy for Synchrotron
- Uniquely brought synchrotron 3D imaging performance to lab based instruments
- Used by premier scientists and industrial researchers worldwide





#### **3D Imaging Technologies**



ZEISS

## **ZEISS X-ray Solutions Portfolio** Solutions for every size and application



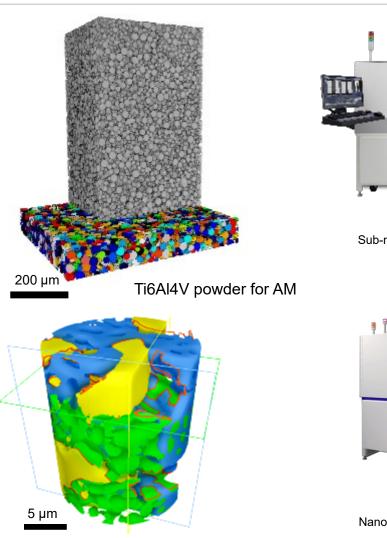
General research			Product-and-process development	Parts manufacturing, Assembly in volume production	
		Xradia Corece			
	ZEISS Xradia Versa/Ultra X-ray microscopes (XRM)	ZEISS Xradia Context microCT	ZEISS METROTOM Computed tomography	SRE MAX from Bosello a company of the ZEISS group	ZEISS VoluMax Computed tomography
Application	High-resolution detail analysis, 3D	Large field of view, full context sub- micron imaging, 3D	Measuring and evaluating entire components	Inspection with high throughput, 2D	Inspection with high throughput
Particular strengths	Resolution in the submicron and nano range	Projection-based geometric mag. High resolution for small samples Field convertible to Versa XRM	Standard-compliant and traceable precision Testing as per VDI/VDE 2630, Evaluation with ZEISS CALYPSO	Customized product design, 2D Radioscope with easy handling Comprehensive project experience	Customized product design, Inline & Atline Computer tomograph Comprehensive project experience
Place of use	Lab	Lab	Measuring lab	In production and near production	In production and near production
Resolution	500 nm (Versa), 50 nm (Ultra)	0.95 μm	3.5 – 6 μm	100– 400µm	3.5– 400μm
Speed	Hours	Hours-Minutes	Minutes	Seconds	Seconds

## **ZEISS X-ray Microscopy for Materials Science** Overview



#### • Non-destructive, state of the art 3D imaging

- Highest resolution
  - Study structures with down to 50 nm resolution
  - Maintain resolution across a wide range of sample sizes
- Highest contrast
  - Synchrotron technology adopted for a lab-source
  - Available 24/7
- Wide range of sample volumes for multi-scale, hierarchical materials (cm<sup>3</sup>  $\rightarrow$  µm<sup>3</sup>)
- Unique modalities
  - 4D material evolution studies, 'time-lapse'
  - High resolution studies within flexible array of *in situ* environments
  - Navigate & correlate:
    - Precursor to complementary and efficient physical sectioning with Crossbeam (3D FIB-SEM)





Xradia 620 Versa Sub-micron 3D X-ray Microscope

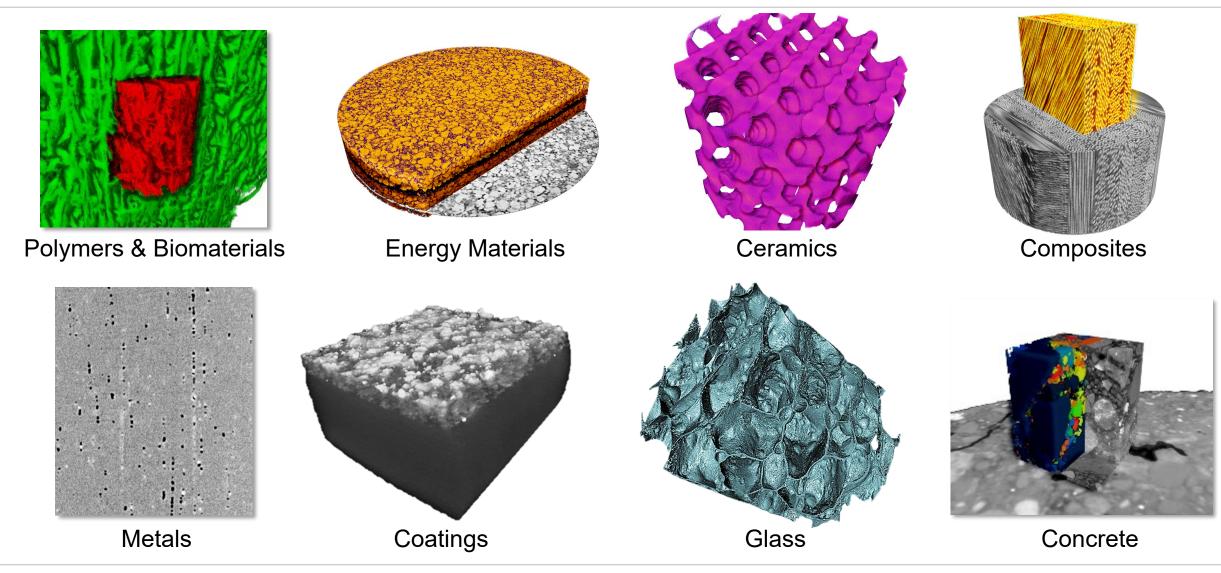


Xradia 810 Ultra Nanoscale 3D X-ray Microscope

Fuel cell electrode

## Materials Science Applications for X-ray microscopy

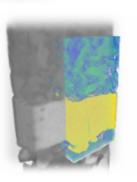




#### Agenda







#### **Overview of ZEISS X-ray Microscopy in Materials Science**

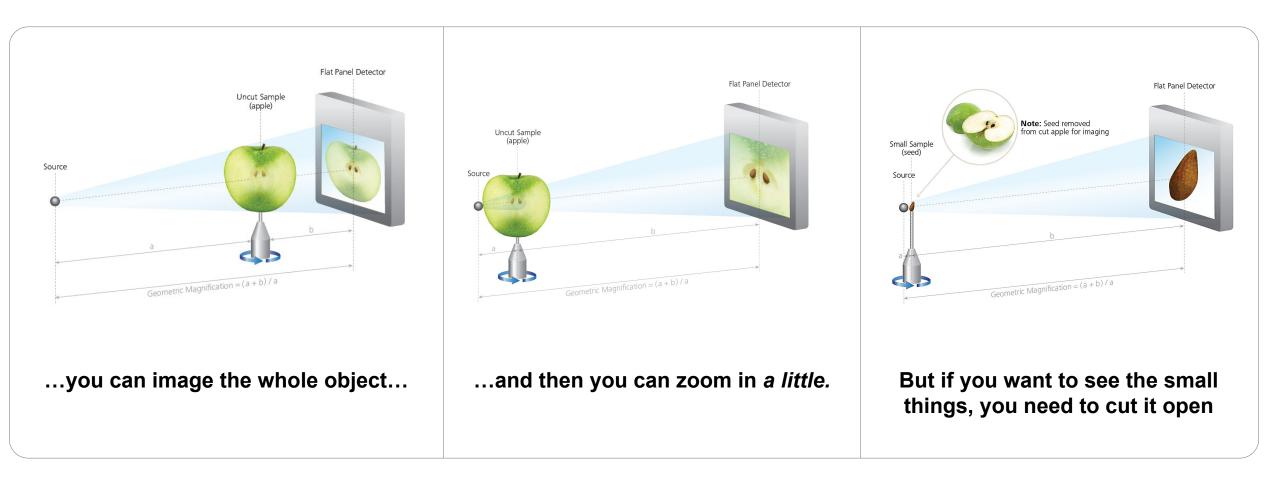
#### **ZEISS Xradia Versa – Technology and Applications**

**ZEISS Xradia Ultra – Technology and Applications** 

## Limitations of microCT Geometric Magnification

"You can only get so close"

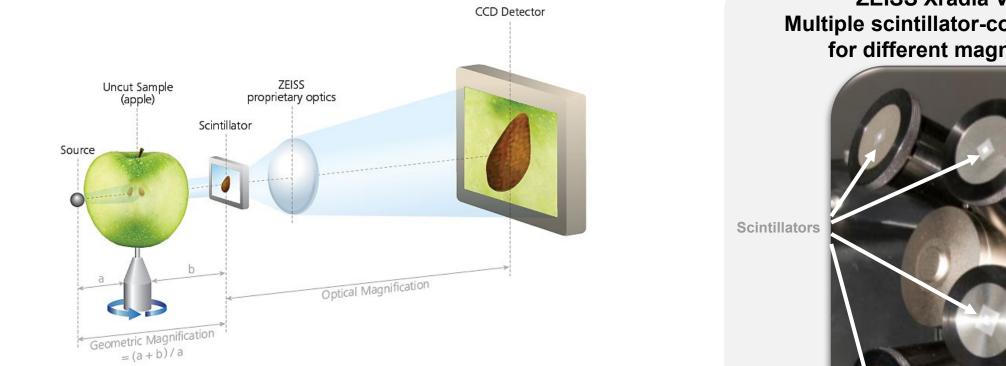
#### With microCT architecture...





### X-ray Microscopy with Two-Stage Magnification Geometric + optical magnification





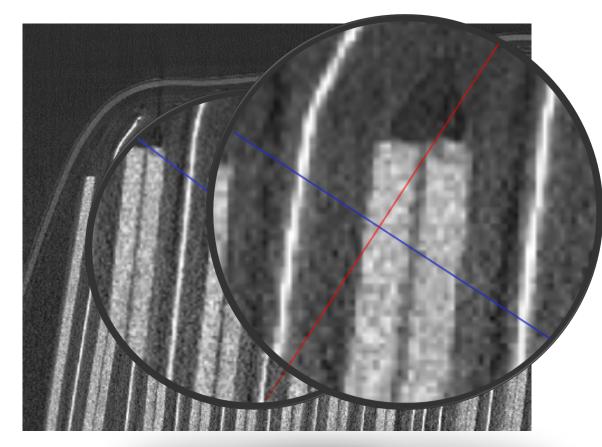
Only an X-ray microscope can scan an apple seed at high resolution *without cutting* the apple open (RaaD = Resolution at a Distance)

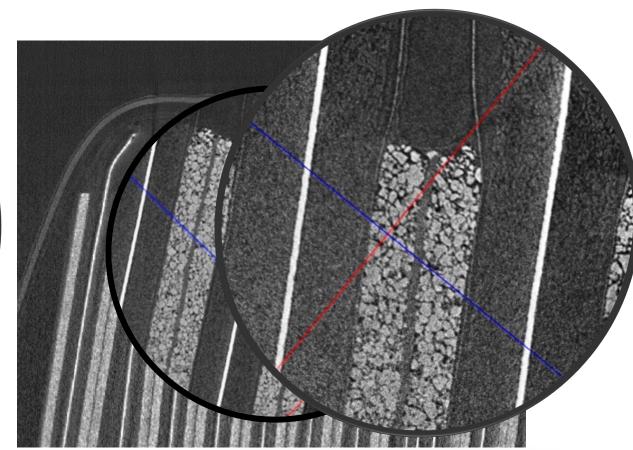
ZEISS Xradia Versa -Multiple scintillator-coupled optics for different magnification **CCD** Detector **Optical Magnification** (not visible)

### **X-ray Microscopy with RaaD** Advantage over microCT – demonstrated on intact Li-ion battery



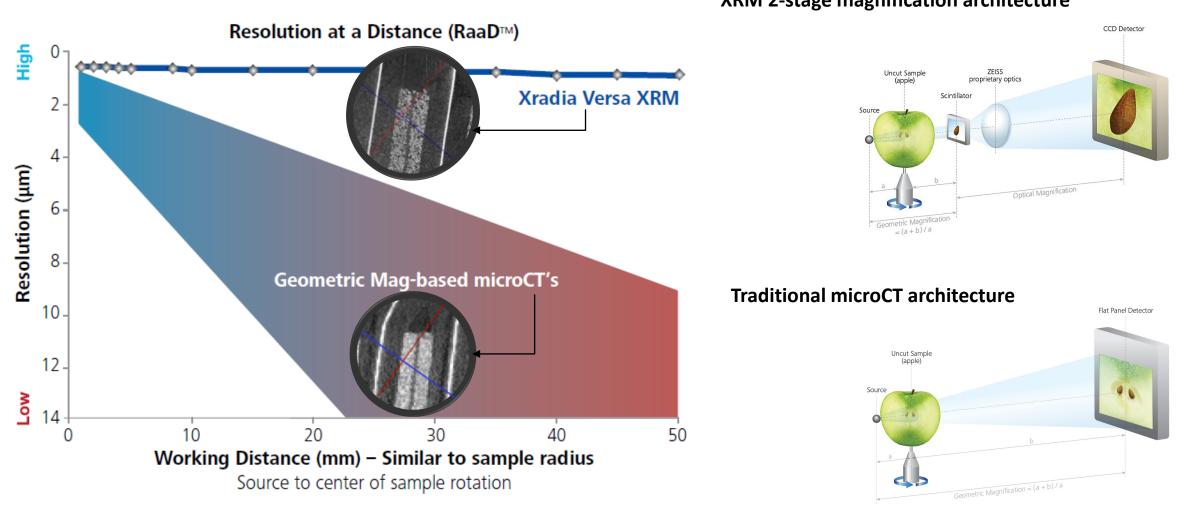
## Traditional X-ray microCT





X-ray microscope

## **XRM** Maintains High Resolution at Large Working Distances



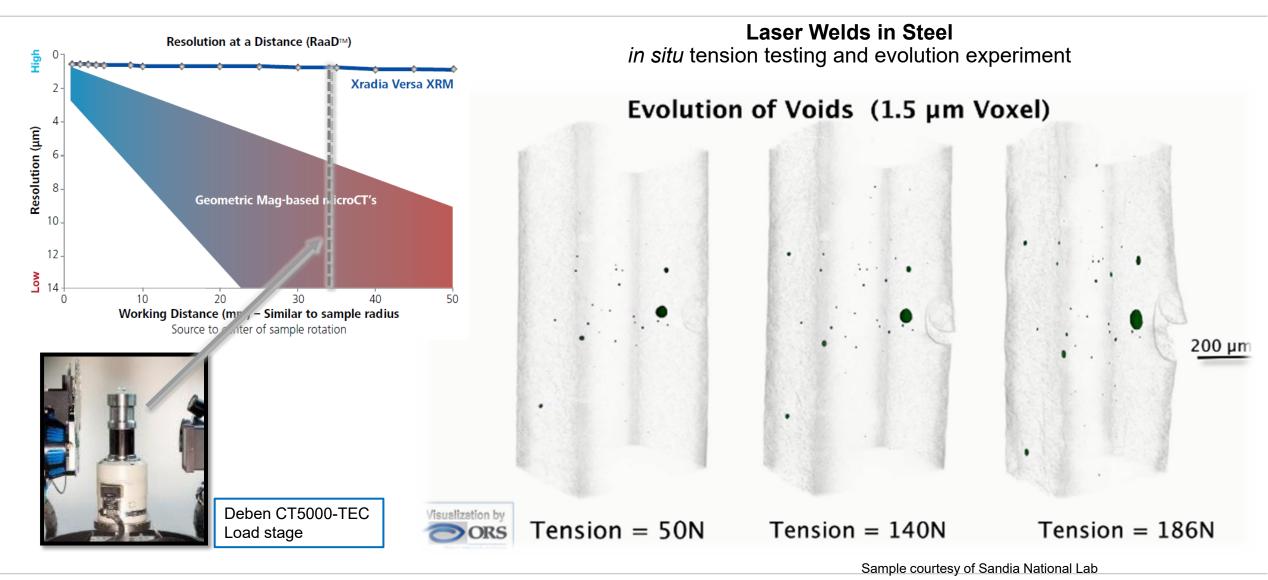
XRM 2-stage magnification architecture

ZEISS

# Resolution at a distance (RaaD<sup>™</sup>)

## Provides best results for imaging in situ experiments

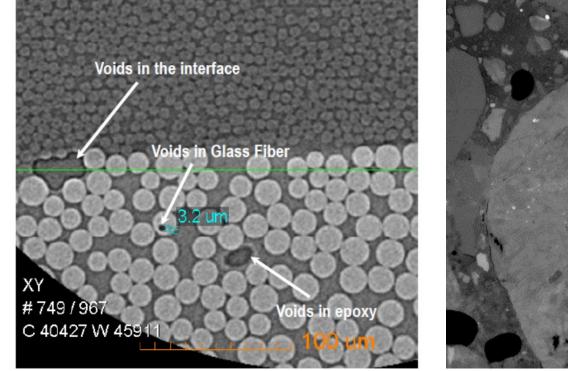




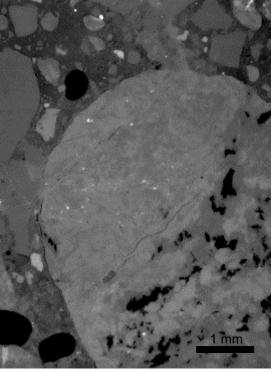


#### **High Absorption Contrast**





Carbon and glass fiber-reinforced polymer

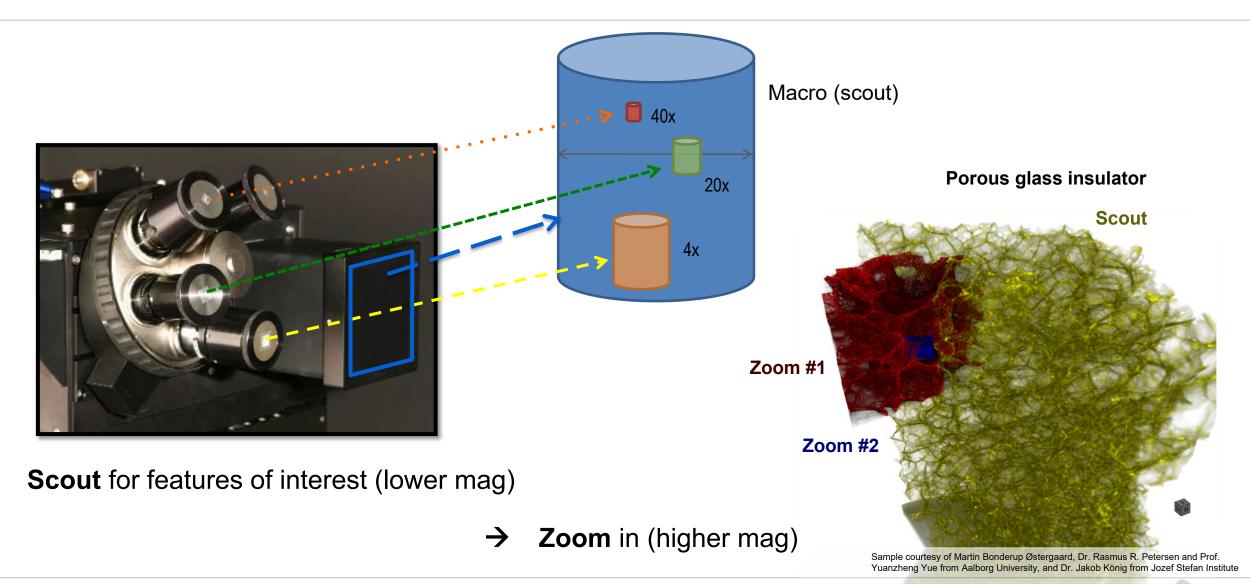


Concrete, interior tomography

Proprietary scintillators optimized by detector

#### **Interior Tomography** Enabled by RaaD

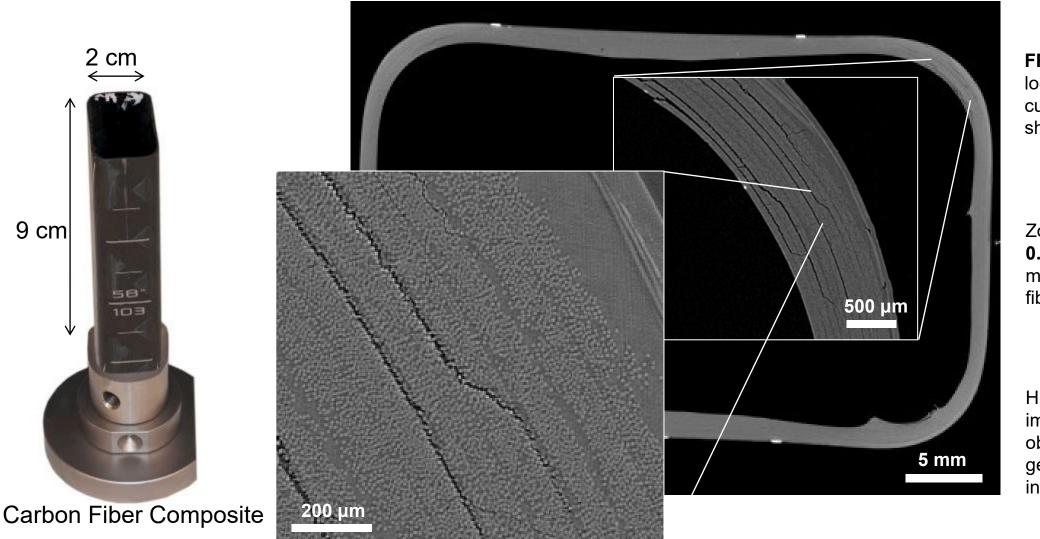




Carl Zeiss Microscopy

#### Hockey stick - Fiber Reinforced Composite "Scout-and-Zoom" workflow





**FPX** is used to identify localized cracks in high curvature regions of shaft

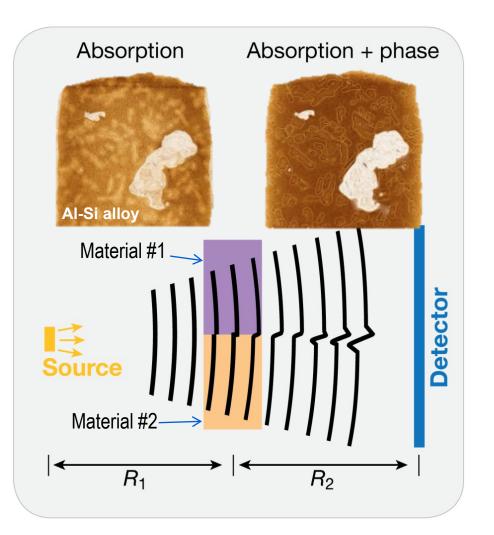
Zooming in with the **0.4X** objective shows many cracks between fiber plies

Higher resolution imaging with the **4X** objective reveals crack geometries relative to individual fibers

Carl Zeiss Microscopy

#### **Xradia Versa: Tunable Propagation Phase Contrast**





#### **Phase Contrast**

- Effect depends upon refraction rather than absorption
- Phase shift related to refractive index differences between materials
- Fringes are very small (microns) and require small detector pixels to detect

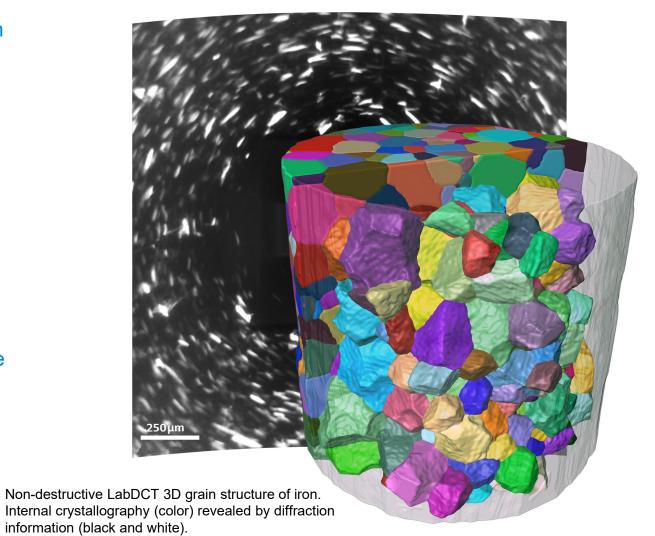
#### **Enabling Technology**

- Small detector pixels (0.34 µm on 40X) to capture fringes
- Both source and detector have large travel lengths to maximize fringe

## LabDCT Unlocking crystallographic information

- Non-destructive 3D grain imaging for mapping orientation and microstructure in 3D for polycrystalline samples metals and alloys
- Combining 3D grain orientation with 3D microstructural features such as defects or precipitates observed in tomography
- Routine tool access enables logitudinal evolution ('4D') experiments studies such as metal corrosion
- Coupling between 3D/4D experiments and microstructure modeling for grain growth kinetics
- Routinely acquire grain statistics on larger volumes to complement correlative investigations (e.g. EBSD)

Carl Zeiss Microscopy





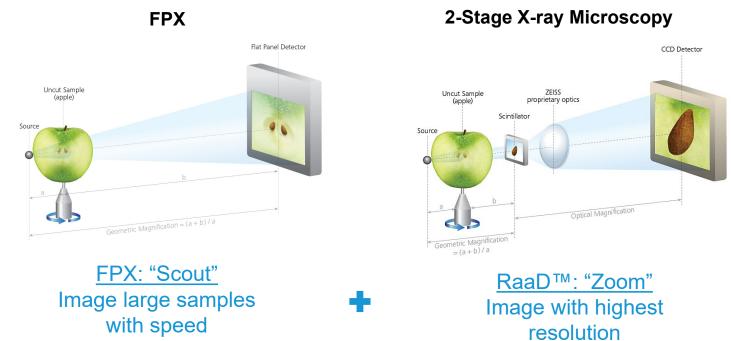
#### Carl Zeiss Microscopy

#### **Xradia Versa with FPX** Overview

## **FPX** – Flat Panel Extension

ZEISS has developed a world-class flat panel system for the Xradia 5XX & 6XX Versa. FPX combines microCT with RaaD<sup>™</sup>, offering the best of both technologies in one system

Versa RaaD<sup>™</sup>

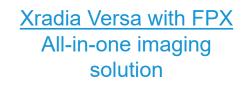


# ору

#### Xradia Versa FPX and RaaD™ systems

Xradia Versa interio

RaaD



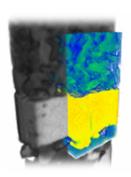
FPX



#### Agenda







#### **Overview of ZEISS X-ray Microscopy in Materials Science**

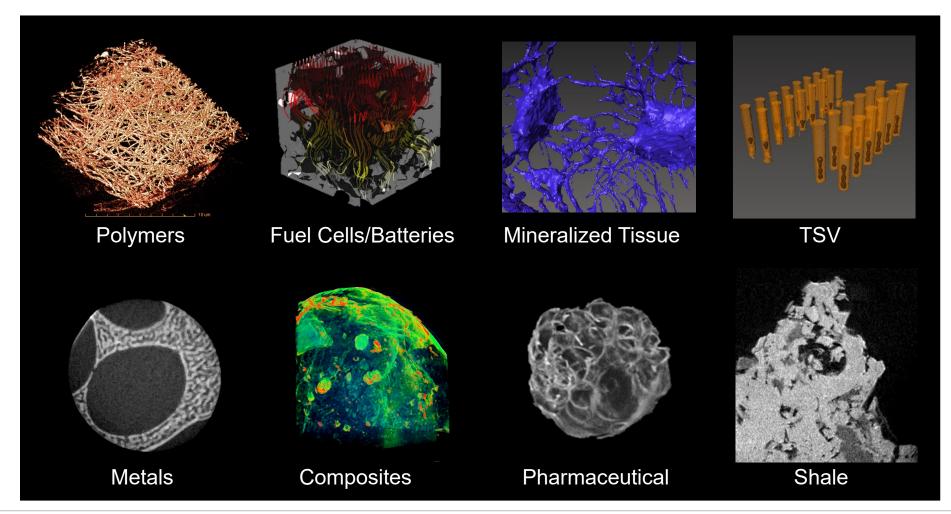
#### **ZEISS Xradia Versa – Technology and Applications**

#### **ZEISS Xradia Ultra – Technology and Applications**

#### **Xradia Ultra** Applications for Research



Diverse interests and applications...

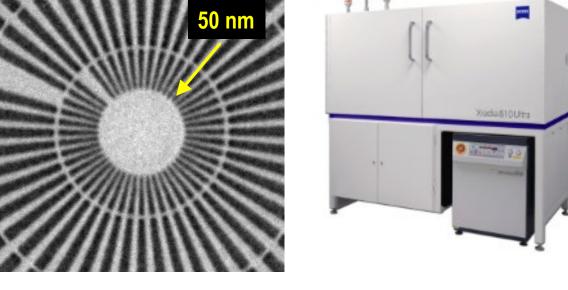


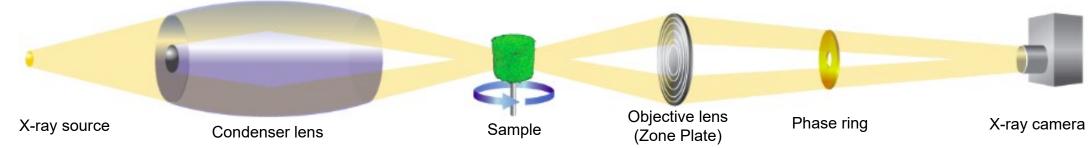
#### **ZEISS Xradia Ultra** 3D X-ray nanotomography down to 50 nm resolution

# The only non-destructive, laboratory based 3D imaging solution with resolution down to 50 nm: Ideal for 4D and *in situ* studies

- High brightness X-ray source
  - Xradia 810 Ultra: 5.4 keV
  - Xradia 800 Ultra: 8.0 keV
- 50 nm spatial (16 nm voxel) resolution
- Advanced X-ray optics
- Absorption and Zernike phase contrast

Mode	Mag	2D Res	Voxel	Field of View
Large Field of View	200X	150 nm	64 nm	65 µm x 65 µm
High Resolution	800X	50 nm	16 nm	16 µm x 16 µm

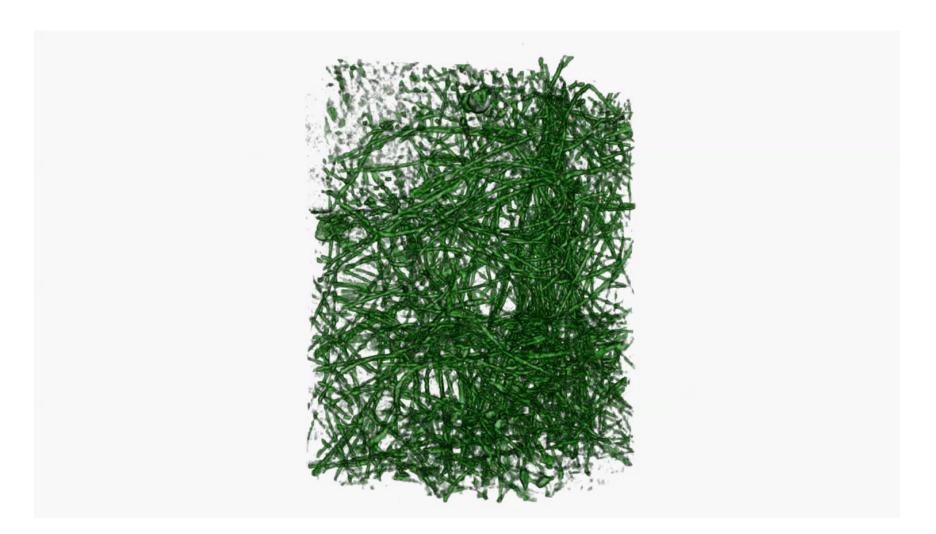






#### Why Do You Need Zernike Phase Contrast? Ideal for low density, weakly absorbing materials

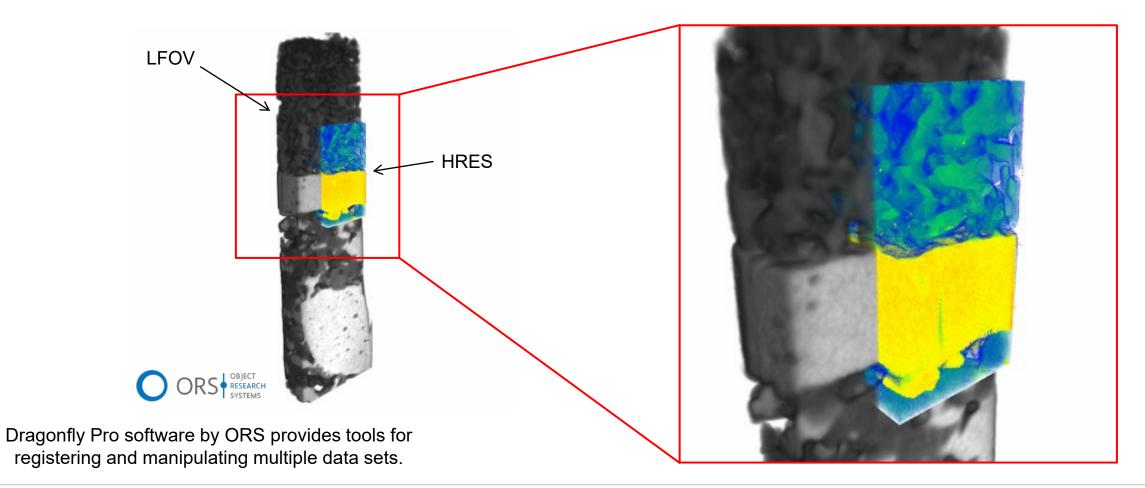




#### Solid Oxide Fuel Cell Multiscale Imaging Ultra LFOV & HRES data registration



LFOV imaging was first performed with the Xradia 810 Ultra. Then a local region of the sample was scanned in the HRES mode. The images below show the HRES and LFOV data sets overlaid onto each other.



## **Xradia Ultra Load Stage**

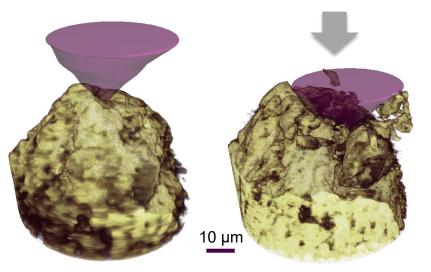
## In situ nanomechanical test stage for 3D X-ray imaging



- The only solution for *in situ* mechanical testing combined with nanoscale 3D imaging
- Study the evolution of interior structure in 3D, under load, down to 50 nm resolution
- Understand how deformation events and failure relate to local nanoscale features and bulk behavior
- Explore a new length scale bridge the gap between SEM/TEM and MicroCT
- Operate in compression, tension or indentation mode

#### Key applications:

- High strength alloys
- Coatings
- Fibers / composites
- Biomaterials / biomechanics
- Building materials
- Foams



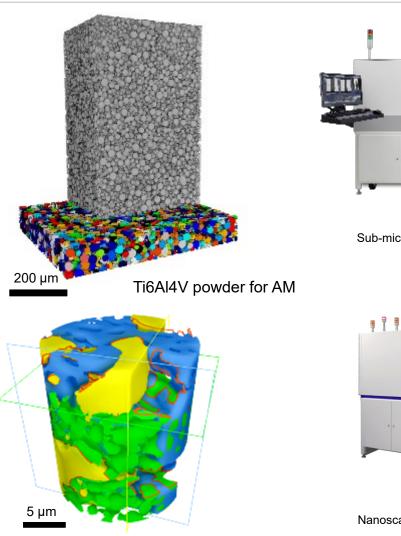
Crack propagation and fracture in dentin Courtesy Univ. Manchester

## **ZEISS X-ray Microscopy for Materials Science** Overview



#### • Non-destructive, state of the art 3D imaging

- Highest resolution
  - Study structures with down to 50 nm resolution
  - Maintain resolution across a wide range of sample sizes
- Highest contrast
  - Synchrotron technology adopted for a lab-source
  - Available 24/7
- Wide range of sample volumes for multi-scale, hierarchical materials (cm3  $\rightarrow$  µm3)
- Unique modalities
  - 4D material evolution studies, 'time-lapse'
  - High resolution studies within flexible array of *in situ* environments
  - Navigate & correlate:
    - Precursor to complementary and efficient physical sectioning with Crossbeam (3D FIB-SEM)





Xradia 620 Versa Sub-micron 3D X-ray Microscope



Xradia 810 Ultra Nanoscale 3D X-ray Microscope

Fuel cell electrode

